## **40/594030** IAPO1 Rec'd PCT/PTO 25 SEP 2008

Docket No.: HEI-022 PATENT

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Confirmation No.

Yutaka SHIBUI et al.

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U.S. Patent Application No.: -----

Group Art Unit: -----

Filed: herewith

For: METHOD OF MACHINING WORK IN NUMERICALLY CONTROLLED

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## INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the documents listed on the attached form PTO-1449. It is respectfully requested that the documents be expressly considered during the prosecution of this application, and that the documents be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement is being filed with the application and no certification or fee is required.

Respectfully submitted,

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Date: September 25, 2006

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Sheet 1 of 1

INFO	ORMATION	DISCLOSURE	ATTY. DOCKET NO. HEI-022		U.S. APPLICATION NO. Not yet assigned		
11 (1	CITATION APPLICA	IN AN	APPLICANT Yutaka SHIBUI et al				
ALLEATION			FILING DATE		GROUP		
(PTO-1449)		herewith					
			DOGUMENTS:				1 1
EXAMINER'S INITIALS	PATENT NO.	DATE	NAME	CLASS	SUBCLASS	FILING DATE	
		FOREIGN PATE	NT DOCUMENTS			The same of the sa	
EXAMINER'S INITIALS	PATENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	Translat Yes	ion No
	JP2001-018101	01/23/2001	Japan			abstract	
	JP2002-341915	11/29/2002	Japan			abstract	
	WO02/24385A1	03/28/2002	PCT			abstract	
	JP2002-341913	11/29/2002	Japan			abstract	
	ОТНЕ	ART (Including Author,	Title: Date. Pertinen	Pages. Et			****
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EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.